



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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APPLICANT(S): Kunihiro Take ATTY DOCKET NO. 09792909-4718
SERIAL NO. 09/732,393 GROUP ART UNIT: 2623
FILING DATE: December 7, 2000 EXAMINER: V. Kibler
INVENTION: "SEMICONDUCTOR WAFER EXAMINATION SYSTEM"

ENTERED
9/13/04
Per filing of
RCE (8-2-04)
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AMENDMENT "B" AFTER FINAL

Mail Stop: Box After Final Amendment
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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MAY 07 2004

Technology Center 2600

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SIR:

This amendment is filed in response to the Final Office Action of January 30, 2004. Please reconsider the application in view of the amendment and remarks presented below.

I hereby certify that this document is being deposited with the United States Postal Service as first class mail in an envelope addressed to: MAIL STOP AFTER FINAL AMENDMENT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 30, 2004.

Mary Ann Smolucka